



IPW

**PATENT APPLICATION**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q84298

Hitoshi KIDOKORO, et al.

Appln. No.: 10/517,656

Group Art Unit: 1725

Confirmation No.: 1603

Examiner: Not yet assigned

Filed: December 13, 2004

For: LASER MACHINING APPARATUS AND CONTROL METHOD FOR THE APPARATUS

**REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT**

**ATTN:** Office of Initial Patent Examination  
Filing Receipt Correction  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

We enclose a copy of the Official Filing Receipt for the above-identified application and request the following correction:

**Change the Title to read -- Laser machining apparatus and control method for the apparatus--.**

Verification for the requested correction is indicated on the Declaration filed December 13, 2004.

Respectfully submitted,

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WASHINGTON OFFICE

**23373**

CUSTOMER NUMBER

Date: December 22, 2005



UNITED STATES PATENT AND TRADEMARK OFFICE



UNITED STATES DEPARTMENT OF COMMERCE  
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/517,656	12/13/2004	1725	1360	Q84298	13	5	2

CONFIRMATION NO. 1603

23373  
SUGHRUE MION, PLLC  
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WASHINGTON, DC 20037

FILING RECEIPT



\*OC000000017574032\*

Date Mailed: 12/05/2005

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. **If an error is noted on this Filing Receipt, please mail to the Commissioner for Patents P.O. Box 1450 Alexandria Va 22313-1450. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).**

Applicant(s)

Hitoshi Kidokoro, Tokyo, JAPAN; —  
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**Power of Attorney:** The patent practitioners associated with Customer Number 23373.

**Domestic Priority data as claimed by applicant**

This application is a 371 of PCT/JP03/07574 06/13/2003 —

**Foreign Applications**

JAPAN 2002-173679 06/14/2002 —

**Projected Publication Date:** 03/16/2006

**Non-Publication Request:** No

**Early Publication Request:** No

**Title**

Laser beam machine and control method of the machine

Laser machining apparatus and control method for the apparatus

**Preliminary Class**

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